

APR 10 2007

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
(Attorney Docket No. 98010CONDIV)

First Inventor: Vlasta BRUSIC

Serial No.: 10/616,335

Filing Date: 09-Jul-03


Title: CHEMICAL MECHANICAL
POLISHING SLURRY USEFUL
FOR COPPER SUBSTRATES

Examiner: Goudreau, G.

Art Unit: 1763

Certificate of Facsimile Transmission

I, Mariejose Monsalvo, hereby certify that this paper and enclosure(s), if any, are hereby being transmitted by facsimile to the US Patent and Trademark Office's central fax No. (571) 273-8300 on 10 APR 2007.


(Sender's signature)

RESPONSE TO OFFICE ACTION

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

This is a reply to the Office Action issued in the above-captioned U.S. patent application on May 31, 2006.

Amendments to the Claims are reflected in the listing of claims beginning on page 2 of this paper.

Remarks begin on page 4 of this paper.

Cabot Microelectronics Corporation
870 North Commons Drive
Aurora, IL, 60504
Tel. (630) 375-5465